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TIANSHUI HUATIAN SENSOR

CYX23/25 SERIES PRESSURE SENSOR



1 Summary

CYX23/25 series oil filled pressure sensor is a joint type flat film sensitive device. It is produced by selecting international advanced highly stable and high precision silicon pressure chip, adopting stress-optimized design of sintering base, through SMD, gold wire bonding, diaphragm welding, high vacuum oil injection, pressure cycle stress relief, high temperature aging, temperature compensation and other processes. More than 30 years of development, production experience and process innovation have given the product excellent stability and excellent performance, which has been widely recognized by users.

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1.1 CYX23/25 series pressure sensor: Recommended thread

The recommended standard thread connection is M20 \times 1.5 and G1/2. The product is used for pressure detection of media compatible with stainless steel 316L, NBR or fluororubber.

1.2 Gauge type CYX23/25 series pressure sensor model + Y for negative pressure measurement

The negative pressure type is produced by negative pressure special process, which can reliably detect the pressure lower than atmospheric pressure. The range is between - 100kPa and 3MPa.

2 Features

- the measuring range is 0kPa \sim 10KPa \cdots 10MPa
- it has the form of gauge pressure G, absolute pressure A and sealing gauge pressure S
- constant current / constant voltage power supply
- isolated structure, suitable for a variety of fluid media
- M20 × 1.5, G1/2 thread optional
- all 316L stainless steel

3 Main uses

- industrial process control
- liquid level measurement
- gas and liquid pressure measurement
- pressure switch and hydraulic system
- medical and food equipment

4 Technical index

4.1 Electrical performance

- power supply: ≤ 3.0mA; DC ≤ 10V DC
- electrical connection: 0.2mm2, 4-color, 100 mm silicone rubber flexible conductor
- common mode voltage output: 50% of current mode input (typical), 40% of voltage type input (typical)
- input impedance: $2.7k \Omega \sim 5k \Omega$
- output impedance: 3.0k Ω ~ 6k Ω
- response time (10% ~ 90%): < 1ms
- insulation resistance: 500M Ω / 100V DC
- allowable overvoltage: 1.5 times full scale

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4.2 Structure performance

diaphragm material: stainless steel 316L

housing material: stainless steel 316L

pressure pipe material: stainless steel 316L

pin lead: Gold Plated Kovar

sealing ring: NBR, fluororubber (optional)

net weight: About 50g (CYX23), 70g (CYX25)

4.3 Environment condition

vibration: no change at 10gRMS, (20-2000) Hz

constant acceleration: 100g, 11ms

• media compatibility: liquid or gas of 316L and NBR (optional fluororubber)

4.4 Base conditions

medium temperature: (25 ± 3) ℃

ambient temperature: (25 ± 3) °C

humidity: (50% ± 10%) RH

environmental pressure: (86 ~ 106) kPa

• power supply: (1.5 ± 0.0015) mA DC

4.5 Standard range, sensitivity output and optional pressure form

Range	Full scale Output (mV)	Typical value	Pressure form	Range	Full scale Output (mV)	Typical value	Pressure form
0∼10kPa	35∼60	45	G	0∼600kPa	90~120	100	G/A
0~20kPa	70~110	90	G	0~1.0MPa	80~120	100	G/A
0~35kPa	55~80	70	G/A	0~1.6MPa	125~185	150	G/A
0∼70kPa	55~80	60	G/A	0~2.0MPa	50~70	60	G/A
0~100kPa	60~85	75	G/A	0~3.5MPa	100~120	110	G/S/A
0~200kPa	65~85	75	G/A	0∼7.0MPa	120~150	135	S/A
0~400kPa	60~80	70	G/A	0∼10MPa	180~230	200	S/A

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4.6 Basic parameters

Parameters	Typical value	Maximum	Company
Zero output	+1	+ 2	MV
Nonlinearity	0.2	0.5	%FS
Hysteresis	0.05	0.08	%FS
Repeatability	0.05	0.08	%FS
Input / output impedance	2.6	5.0	ΚΩ
Zero temperature drift note 1	±0.4	±1.0	%FS, @25℃
Sensitivity temperature drift note 2	±0.4	±1.0	%FS, @25℃
Long term stability	0.2	0.3	%FS / year
Exciting current	Exciting current 1.5(the maximum input voltage can be 10V)		
Insulation resistance	500 (10	МΩ	
Compensation temperature note 3	0~50; -10	℃	
Working temperature	-40 ~	℃	
Storage temperature	-40~	°C	
Response time	≤	ms	
Housing and diaphragm material	316L stair		
Ed seal ring	18.5× 23.9 Fluororubber ^{not}		
Measuring medium	Fluids compatible with fluoroels		
Life (25 °C)	> 1 × 108 pressur	times	
Filling medium	silico		

Note 1 & note 2: The typical value of zero temperature drift and sensitivity temperature drift of 0-10kPa is $0.5\%FS@25^{\circ}C$, maximum $1.2\%FS@25^{\circ}C$.

Note 3: 200kPa and below range, compensation temperature 0 to 50°C; above 200kPa, compensation temperature -10°C to 70°C.

Note 4: The temperature resistance range of fluororubber seal ring is - 20 $^{\circ}$ C $^{\circ}$ 200 $^{\circ}$ C, and its low temperature performance is poor. When the temperature range is lower than -20 $^{\circ}$ C, please verify the use.

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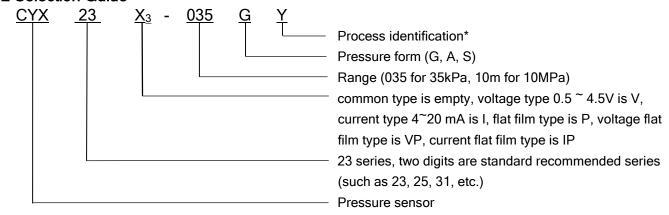
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5 Selection structure

5.1 Model selection and outline drawing

5.1 Model selection and outline drawing				
Series	Range	Model	Outline drawing	
CYX23/P		CYX23	SELVE SERVICE STATE OF THE PROPERTY OF THE PRO	
	-100kPa∼10MPa	CYX23P	STILL STATE OF THE	
CYX25/P	-100kPa∼10MPa	CYX25	\$1 15.2 10 1 1 X 52 1 X	
		CYX25P	ESEXIES ESEXIE	

5.2 Selection Guide

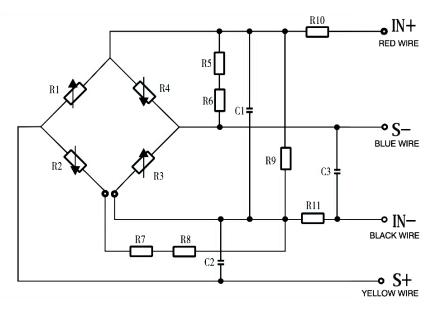


^{*}Process identification: f is general process, Y is negative pressure process

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6 Schematic diagram and wiring mode



IN+ (red wire) - positive supply

IN- (black wire) - negative supply

S+ (yellow wire) - positive output

S- (blue wire) - negative output

7 Application Tips

- The sealing method of the pressure sensor is recommended for the hexagonal ED seal structure. Avoid excessive torque affecting the stability of the pressure sensor during thread installation. The recommended torque is not greater than the following values according to the pressure range: 0∼500kPa, 0.9Nm; 500kPa∼2MPa, 1.1Nm; 2MPa∼10MPa, 1.6Nm.
- Pay attention to protect the front diaphragm and the compensation circuit board at the back end of the pressure sensor, so as not to damage the performance or cause damage to the sensor.
- Do not press the metal diaphragm with hands or hard objects to avoid damage to the sensor due to chip deformation or perforation
- The ventilation pipe at the rear of the G-type sensor should be connected with the atmosphere; water, water vapor or corrosive media are not allowed to enter the reference chamber at the rear of the sensor.
- Avoid falling, hitting, etc., which will affect the stability of the sensor
- In case of change in the pin lead, the label carried by the sensor shall prevail.